

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Akihiko ENDO et al. Group Art Unit : 2891
Appl. No. : 10/570,669 Examiner : Asak K SARKAR
Filed : March 6, 2006 Confirmation No. : 1242
For : SOI WAFER AND ITS MANUFACTURING METHOD

REQUEST FOR EXTENSION OF TIME


Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

A request is hereby made for a one-month extension of time for responding to the Office Action mailed from the U.S. Patent and Trademark Office on October 27, 2008, i.e., from January 27, 2009 to and including February 27, 2009. The fee for a one-month extension of time is being paid concurrently herewith.

The Patent and Trademark Office is hereby authorized to credit any overpayment or charge any additional fee to Deposit Account No. 19-0089.

Respectfully Submitted,
Akihiko ENDO et al.


William S. Boshnick
Reg. No. 44550

February 20, 2009
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191

Stephen M. Roylance
Reg. No. 31,296